

| L Number | Hits | Search Text | DB | Time stamp |
|----------|-------|---|--------------------|------------------|
| - | 77203 | lithography patterning | USPAT; US-PGPUB | 2003/06/10 10:49 |
| - | 46889 | beam with radiation) (flood with electron with beam | USPAT; US-PGPUB | 2003/06/10 10:49 |
| - | 5073 | (lithography patterning) and (beam with radiation) (flood with electron with beam) | USPAT; US-PGPUB | 2003/06/09 14:09 |
| - | 2306 | ((lithography patterning) and (beam with radiation) (flood with electron with beam)) and (photoresist) | USPAT; US-PGPUB | 2003/06/09 14:09 |
| - | 80 | ((lithography patterning) and (beam with radiation) (flood with electron with beam)) and (photoresist)) and etching with polysilicon | USPAT; US-PGPUB | 2003/06/10 10:51 |
| - | 25 | 5139904.URPN. | USPAT | 2003/06/09 14:58 |
| - | 1 | 6183937.URPN. | USPAT | 2003/06/09 14:59 |
| - | 7 | ("5139904" "5965461" "6107172" "6121155" "6153477" "6183937" "6232048").PN. | USPAT | 2003/06/09 14:59 |
| - | 19 | ((lithography patterning) and (beam with radiation) (flood with electron with beam)) and (photoresist)) and trim with etch\$3 | USPAT; US-PGPUB | 2003/06/09 15:29 |
| - | 14 | ("5264076" "5773199" "5837428" "5858621" "6080678" "6096659" "6136679" "6156629" "6218292" "6221776" "6297170" "6352922" "6365529" "6410421").PN. | USPAT | 2003/06/09 15:50 |
| - | 23 | 5773199.URPN. | USPAT | 2003/06/09 15:51 |
| - | 12 | ("Re30505" "3920483" "4253888" "5139904" "5308742" "5326727" "5368989" "5407787" "5656128" "5733714" "5753418" "5773199").PN. | USPAT | 2003/06/09 15:52 |
| - | 14 | ("4625120" "4749436" "4868095" "4876177" "5096802" "5300403" "5385804" "5635333" "5641715" "5648198" "5650262" "5652084" "5660957" "5837428").PN. | USPAT | 2003/06/09 16:02 |
| - | 6 | ((("6232048") or ("6197687") or ("6110837") or ("5876903") or ("5468595") or ("3997367")).PN. | USPAT; US-PGPUB | 2003/06/10 10:48 |
| - | 4752 | ((430/328) or (438/671) or (438/723) or (430/313) or (430/296) or (438/371) or (438/719) or (438/720)).CCLS. | USPAT; US-PGPUB | 2003/06/10 10:49 |
| - | 77388 | lithography patterning | USPAT; US-PGPUB | 2003/06/10 10:49 |
| - | 78540 | beam with radiation) (flood with electron with beam | USPAT; US-PGPUB | 2003/06/10 10:50 |
| - | 2659 | ((430/328) or (438/671) or (438/723) or (430/313) or (430/296) or (438/371) or (438/719) or (438/720)).CCLS.) and (lithography patterning) | USPAT; US-PGPUB | 2003/06/10 10:50 |
| - | 559 | ((430/328) or (438/671) or (438/723) or (430/313) or (430/296) or (438/371) or (438/719) or (438/720)).CCLS.) and (lithography patterning)) and (beam with radiation) (flood with electron with beam) | USPAT; US-PGPUB | 2003/06/10 10:50 |
| - | 80 | ((lithography patterning) and (beam with radiation) (flood with electron with beam)) and (photoresist)) and etching with polysilicon | USPAT; US-PGPUB | 2003/06/10 10:51 |
| - | 26 | ((430/328) or (438/671) or (438/723) or (430/313) or (430/296) or (438/371) or (438/719) or (438/720)).CCLS.) and (lithography patterning)) and (beam with radiation) (flood with electron with beam)) and (((lithography patterning) and (beam with radiation) (flood with electron with beam)) and (photoresist)) and etching with polysilicon) | USPAT; US-PGPUB | 2003/06/10 10:51 |